



Docket No.: 52352-785

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

George Jonathan KLUTH, et al.

Serial No.: 10/071,207

Group Art Unit: 2811

Filed: February 11, 2002

Examiner:

For: METHOD OF MANUFACTURING A SEMICONDUCTOR DEVICE WITH  
SUPERSATURATED SOURCE/DRAIN EXTENSIONS AND METAL SILICIDE  
CONTACTS

TRANSMITTAL OF FORMAL DRAWINGS

Commissioner for Patents  
Washington, DC 20231

Sir:

At the time the above application was filed, informal drawings were presented with the application.

The formal drawings are submitted herewith.

Respectfully submitted,

MCDERMOTT, WILL & EMERY

*Bernard P. Codd*

Bernard P. Codd

Registration No. 46,429

600 13<sup>th</sup> Street, N.W.  
Washington, DC 20005-3096  
(202)756-8000 BPC:kjw  
Facsimile: (202)756-8087  
Date: June 7, 2002

10071207.050702

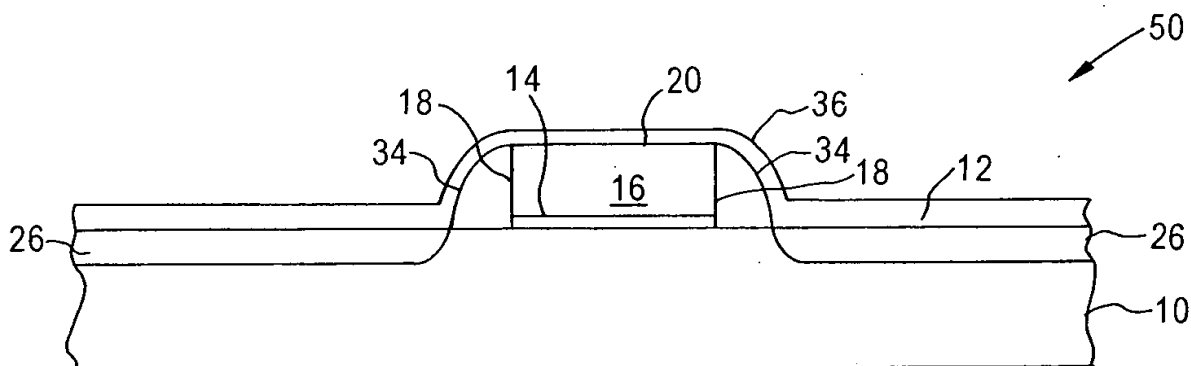


FIG. 1A  
(PRIOR ART)

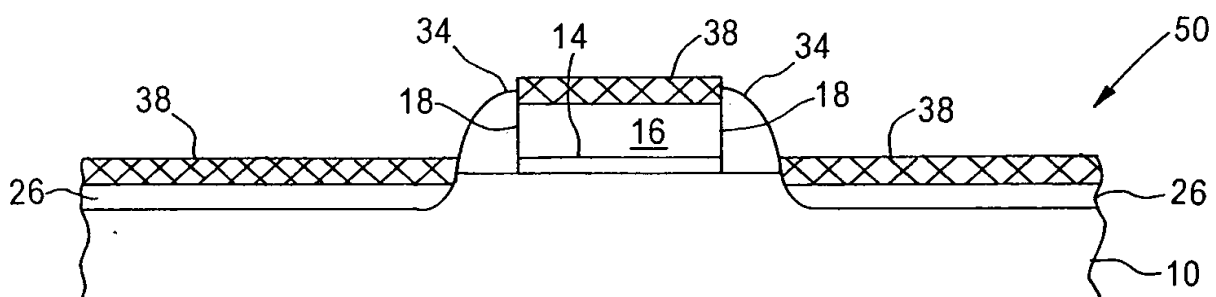


FIG. 1B  
(PRIOR ART)

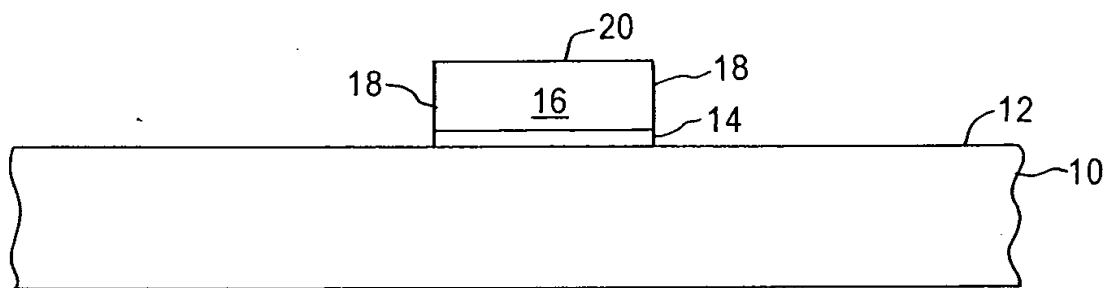


FIG. 2A

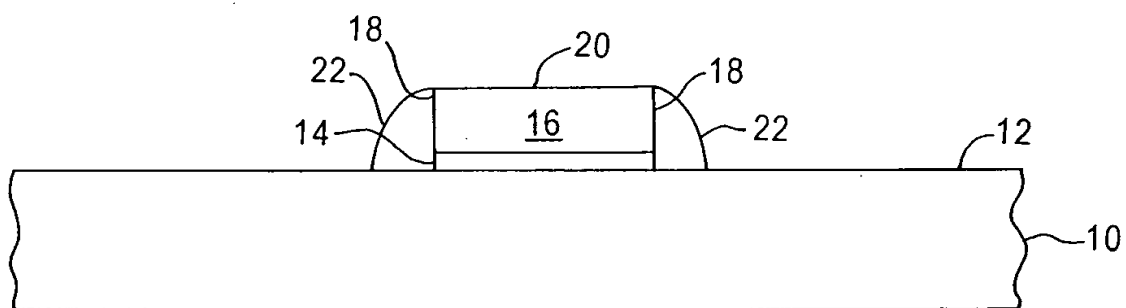


FIG. 2B

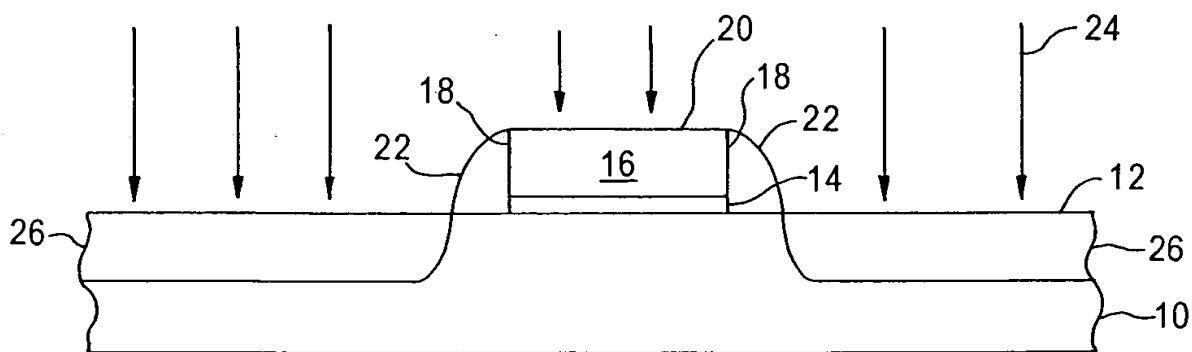


FIG. 2C

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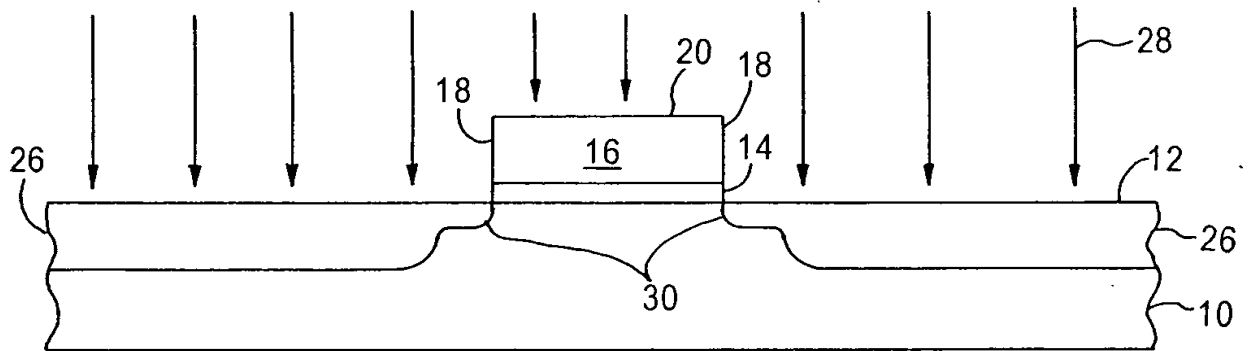


FIG. 2D

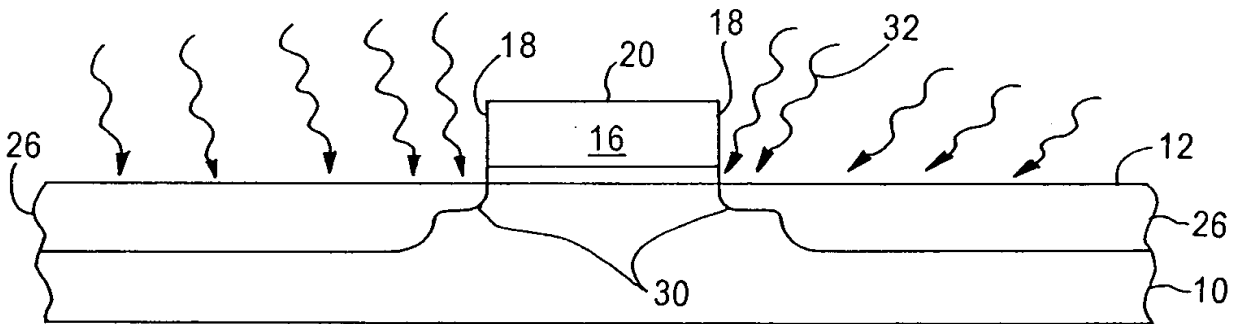


FIG. 2E

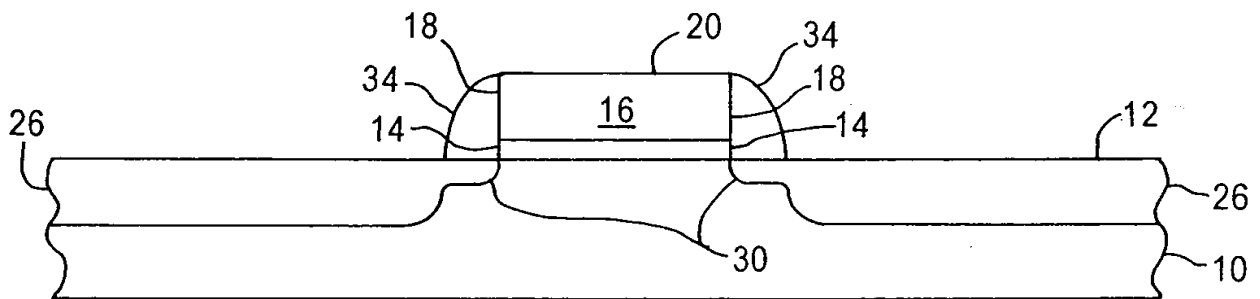


FIG. 2F

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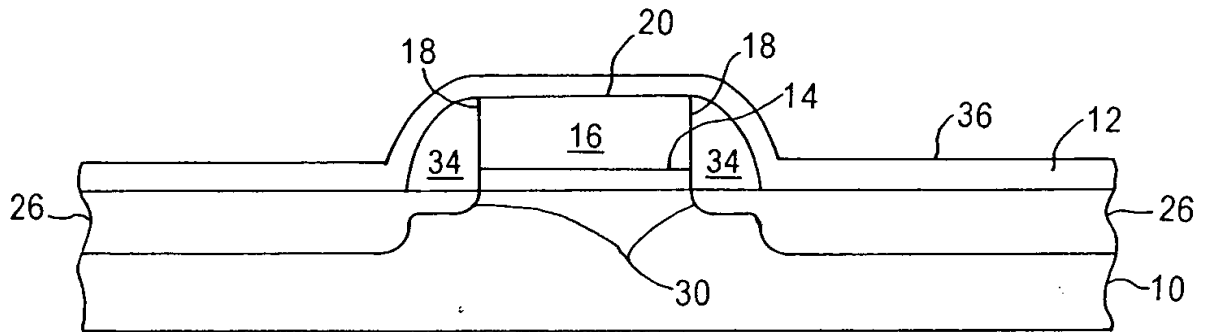


FIG. 2G

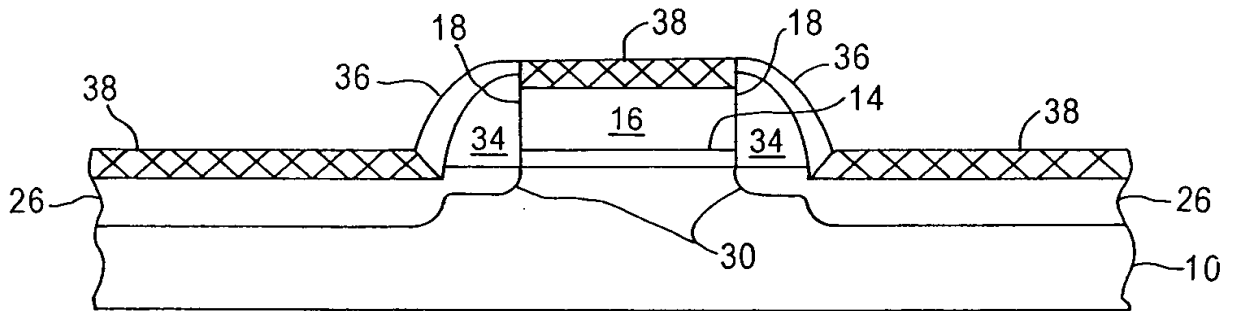


FIG. 2H

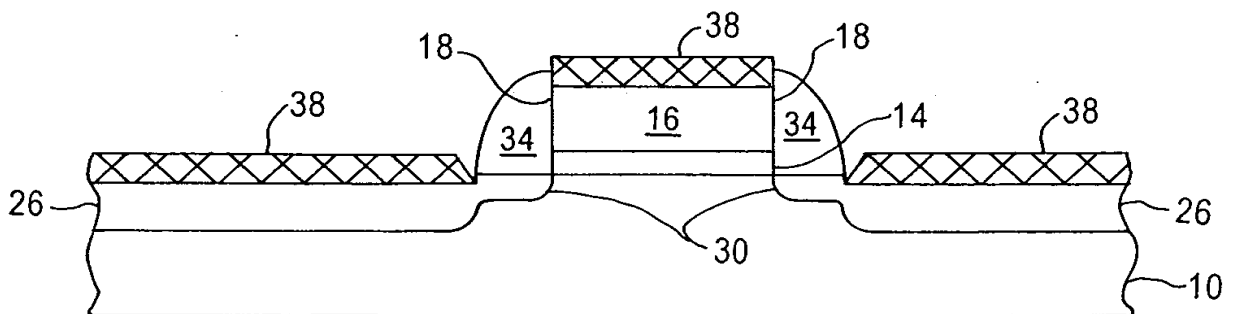


FIG. 2I

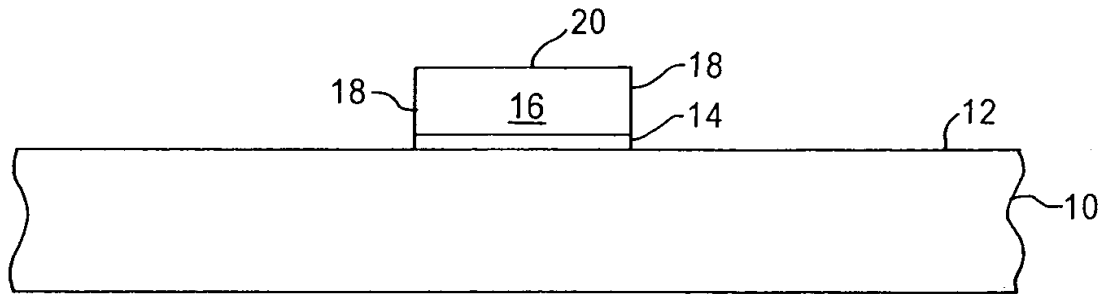


FIG. 3A

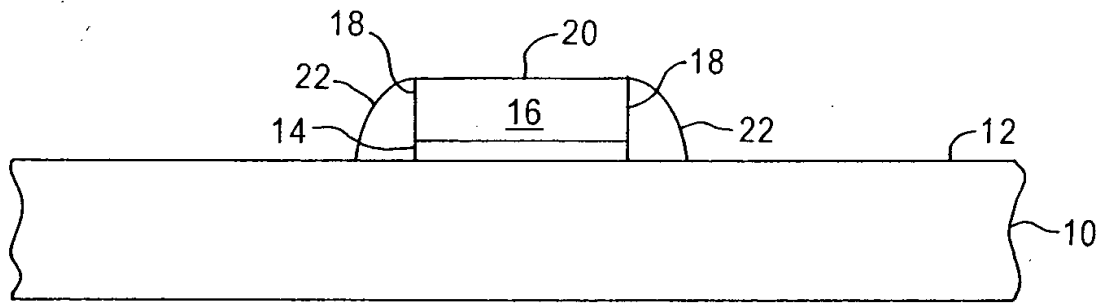


FIG. 3B

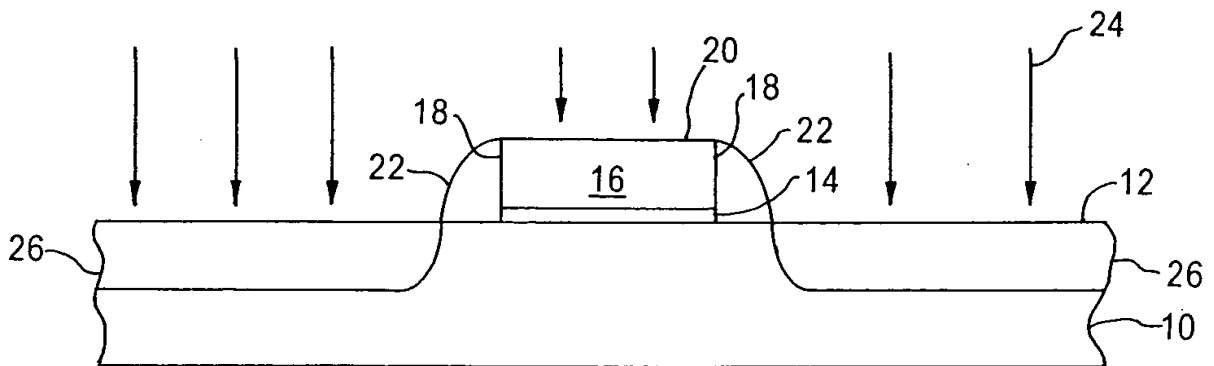


FIG. 3C

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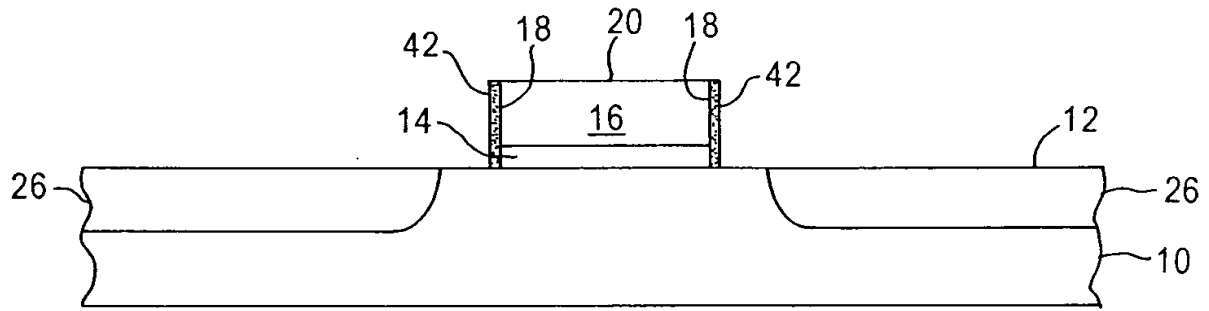


FIG. 3D

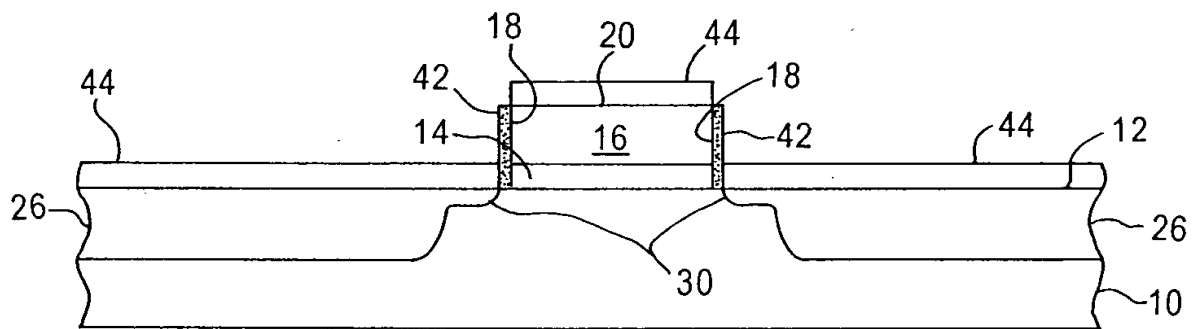


FIG. 3E

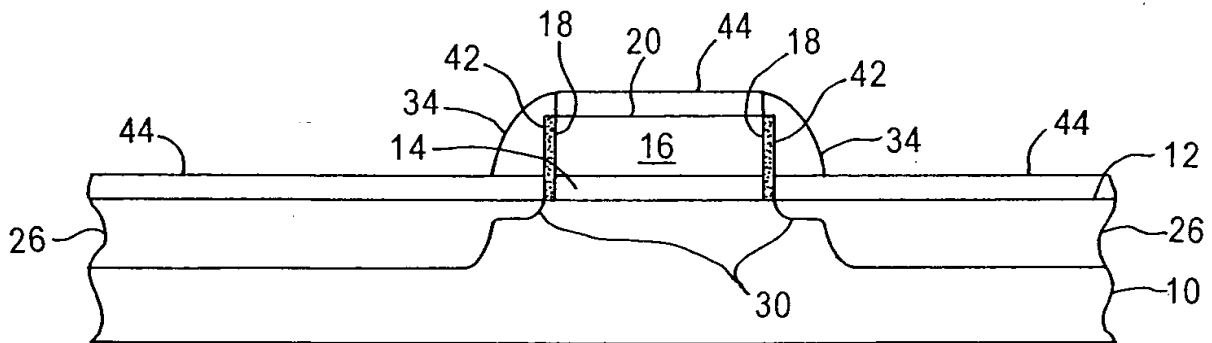


FIG. 3F

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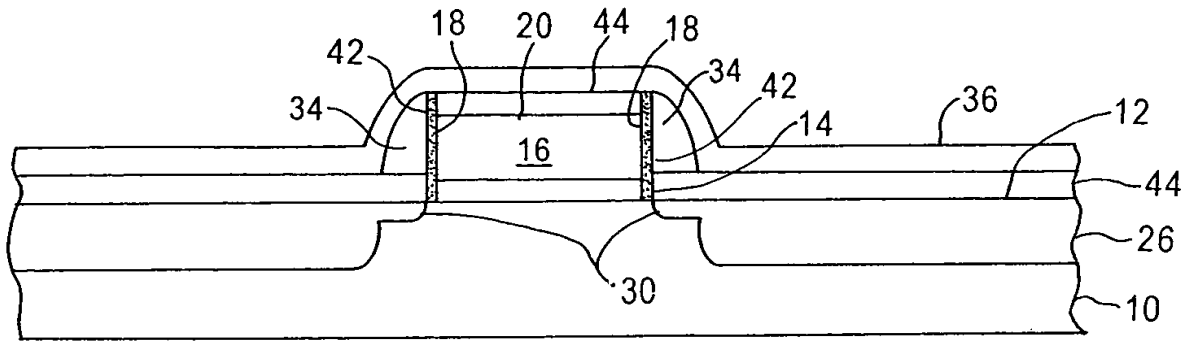


FIG. 3G

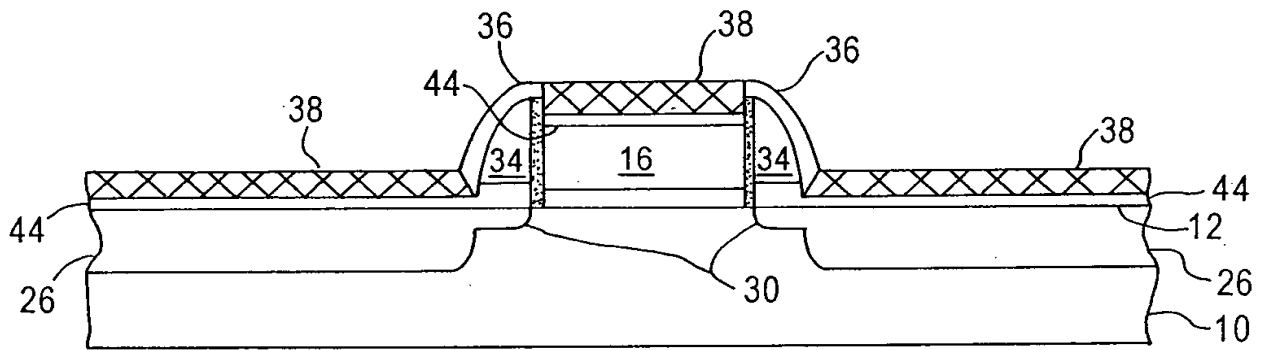


FIG. 3H

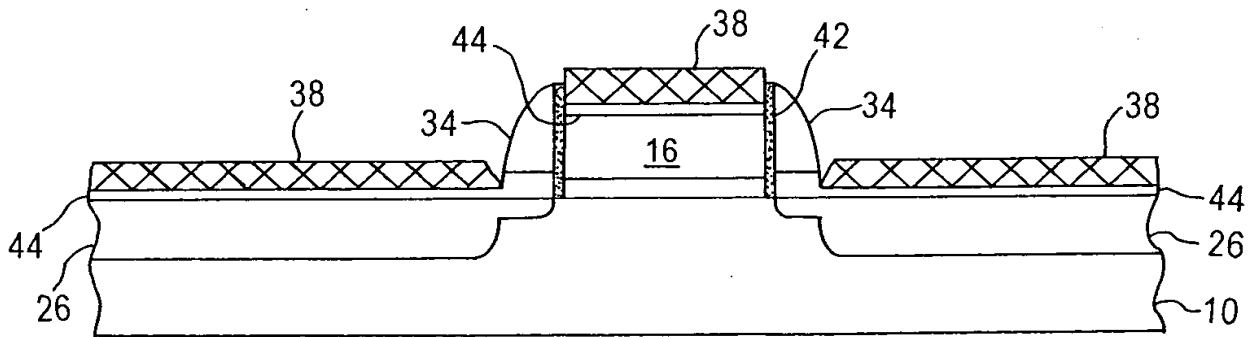


FIG. 3I



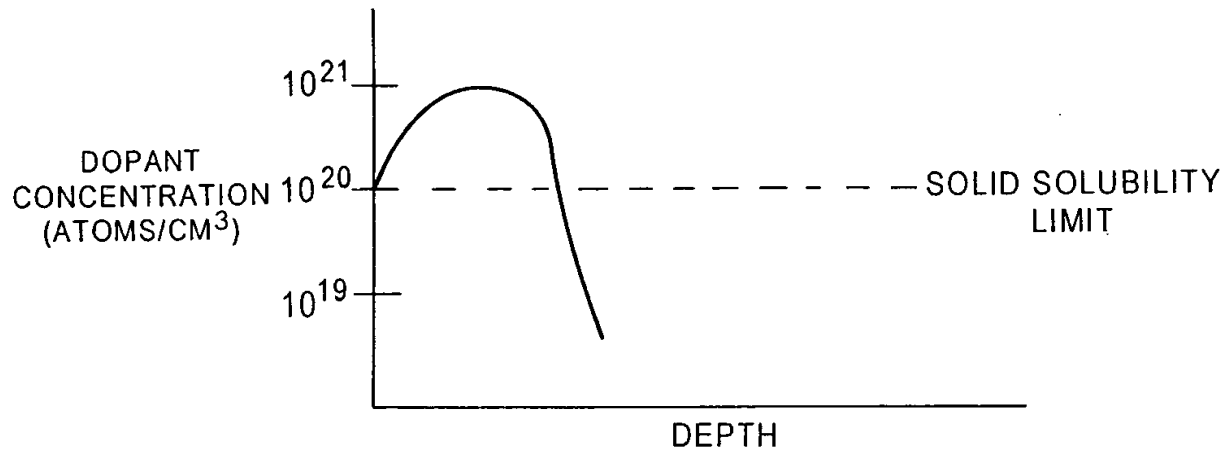


FIG. 4

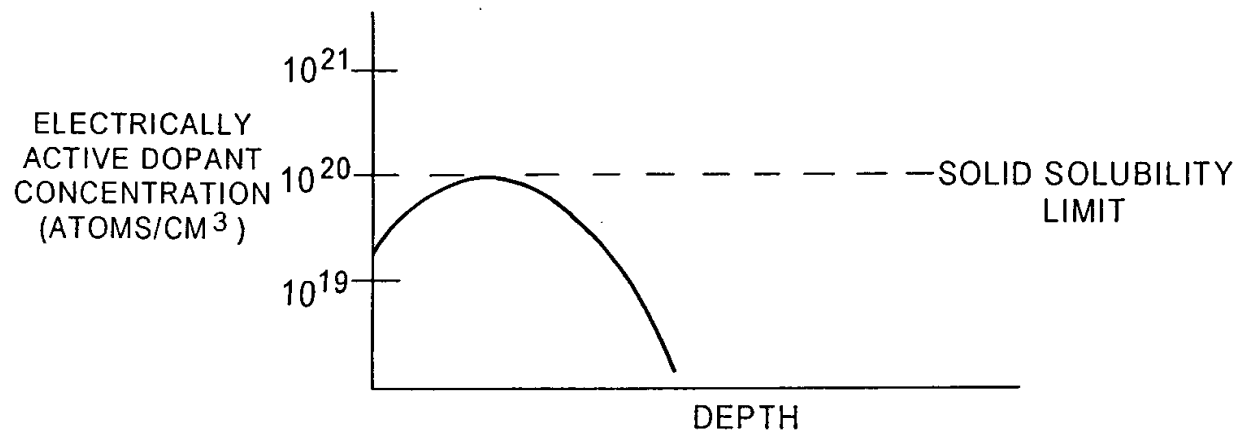


FIG. 5

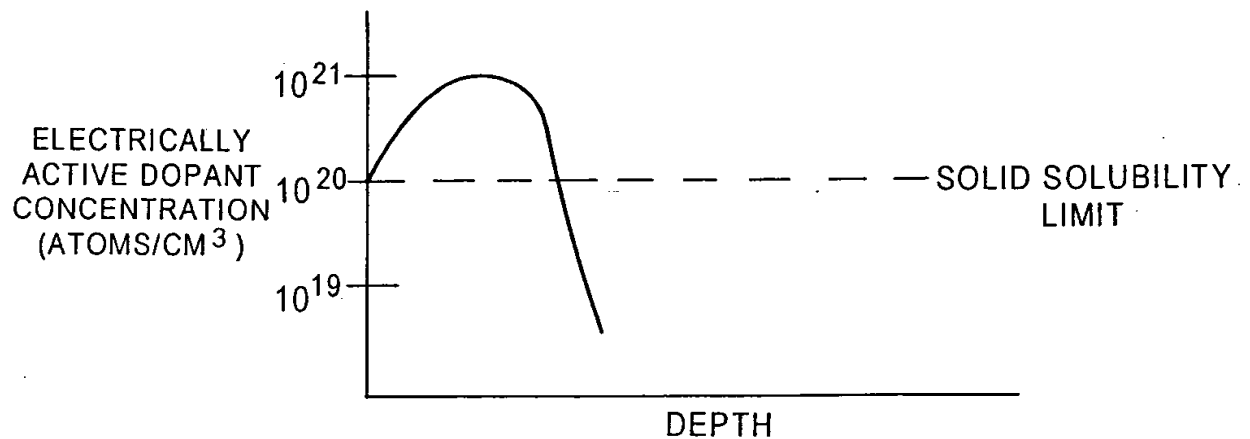


FIG. 6

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